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Perspectives on Advanced Complementary Metal–Oxide–Semiconductor Technology

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Message from the Guest Editors

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- **CMOS Digital Circuits and SoCs:** CMOS circuits with digital-dominated innovation, building blocks such as high-speed, low-voltage or low-power digital circuits, and CMOS IC prototypes in technologies that enhance the efficiency, performance, or reliability of integrated systems.





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Message from the Editor-in-Chief

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